

Docket No.: 61282-034

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
	:	
Mitsumi ITO, et al.	:	Confirmation Number:
	:	
Serial No.:	:	Group Art Unit:
	:	
Filed: August 06, 2003	:	Examiner:
	:	
For:		SEMICONDUCTOR DEVICE, METHOD OF GENERATING PATTERN FOR SEMICONDUCTOR DEVICE, METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE AND DEVICE FOR GENERATING PATTERN USED FOR SEMICONDUCTOR DEVICE

CLAIM OF PRIORITY

Mail Stop CPD
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:


In accordance with the provisions of 35 U.S.C. 119, Applicants hereby claim the priority of:

Japanese Patent Application No. 2002-229216, filed August 6, 2002

cited in the Declaration of the present application. A certified copy will be filed in due course.

Respectfully submitted,

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